Notice of Allowability	Application No.	Applicant(s)		
	10/706,061	CHENG ET AL.	CHENG ET AL.	
	Examiner	Art Unit	lear	
	Stanetta D. Isaac	2812		
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comming IGHTS. This application is:	n this application. If not include unication will be mailed in due o	d course. THIS	
1. \boxtimes This communication is responsive to <u>the amendment and</u>	RCE filed on 9/09/05.			
2. The allowed claim(s) is/are 31-56.				
 3. Acknowledgment is made of a claim for foreign priority unal All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	e been received.			
3. ☐ Copies of the certified copies of the priority do			ion from the	
International Bureau (PCT Rule 17.2(a)).		g		
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file IENT of this application.	e a reply complying with the requ	uirements	
4. A SUBSTITUTE OATH OR DECLARATION must be submined informal patent application (PTO-152) which give			OTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.			
(a) ☐ including changes required by the Notice of Draftspers		w (PTO-948) attached		
1) ☐ hereto or 2) ☐ to Paper No./Mail Date	,			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or	r in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			back) of	
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 	SIT OF BIOLOGICAL MATE FOR THE DEPOSIT OF BIO	ERIAL must be submitted. No DLOGICAL MATERIAL.	ote the	
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of In	formal Patent Application (PTO	-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview S	ummary (PTO-413),	•	
3. M Information Disclosure Statements (PTO-1449 or PTO/SB/0		/Mail Date Amendment/Comment		
Paper No./Mail Date <u>9/09/05</u> 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's	Statement of Reasons for Allow	vance	
-	9. 🗌 Other	2011114	1112	
	Ñ SUPER	MULLI FOLLANGICHAEL LEBENTRITT IVISORY PATENT EXAMINE	ER	

EXAMINER'S AMENDMENT/COMMENTS

An examiner's amendment/comments to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 9/09/05 has been entered.

Information Disclosure Statement

The information disclosure statement (IDS) was submitted on 9/09/05. The submission is in compliance with the provisions of 37 CFR 1.97. Accordingly, the information disclosure statement is being considered by the examiner.

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

The closest prior art of record, Sugii et al., US Patent 6,723,541 in view of Forbes Patent Application Publication US 2004/0235264, fails to show, pertaining to claims 31, 49 and 55,

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"after forming the plurality of channels, removing the top layer of the multi-layer substrate

underneath the Si_{1-x}Ge_x layer to form a void defined by an undercut border in the multi-layer

substrate underneath the Si_{1-x}Ge_x layer to form a void defined by an undercut border in the multi-

layer substrate;"

Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Stanetta D. Isaac whose telephone number is 571-272-1671. The

examiner can normally be reached on Monday-Friday 9:30am -6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Stanetta Isaac Patent Examiner

September 23, 2005

MICHAEL LEBENTRITT
SUPERVISORY PATENT EXAMINER

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